Research Article

I-V Characteristics of Pt$_x$Co$_{1-x}$ ($x = 0.2, 0.5, \text{and} 0.7$) Thin Films

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Three different chemical ratios of Pt$_x$Co$_{1-x}$ thin films were grown on p-type native oxide Si (100) by Magneto Sputtering System with cosputtering technique at 350°C temperature to investigate electrical properties. X-ray photoelectron spectroscopy analysis technique was used to specify chemical ratios of these films. The current-voltage (I-V) measurements of metal-semiconductor (MS) Schottky diodes were carried out at room temperature. From the I-V analysis of the samples, ideality factor (n), barrier height ($\phi$), and contact resistance values were determined by using thermionic emission (TE) theory. Some important parameters such as barrier height, ideality factor, and serial resistance were calculated from the I-V characteristics based on thermionic emission mechanism. The ideality factors of the samples were not much greater than unity, and the serial resistances of the samples were also very low.

1. Introduction

Thin films have nowadays very wide usage area in technological applications [1–6]. They show very distinct difference from bulk films such as Curie temperature and the electrical properties. They get more and more important with the preparation systems progress. In particular after Ultra High Vacuum (UHV) systems became popular, they have been prepared with good quality and cleanliness [1]. There are several preparation techniques to meet user’s need. Some of them for UHV systems are magnetron sputtering deposition, molecular beam epitaxial and e-beam evaporation, and pulse laser deposition [7]. Due to the advantages of the preparation techniques, thin films started being used widely in technological applications such as optics [2], optoelectronics [3], electronics [4], magnetic applications [5], and sensors [6]. Firstly, thin films were prepared as a single layer with monoelement structure. After a little while due to some technological requirements, they started being prepared as multilayer structures and alloy forms with two or more elements. Multilayer forms started to be popular after Giant Magneto Resistance (GMR) [8, 9] effect and Tunneling Magneto Resistance (TMR) [10] effect were observed in the 1980s. The other thin film form is alloy film which started solving some of technological problems, and they gained more importance when compared to single layer films. When two or more elements compose themselves to be alloys, generally every one of them loses some of its own properties and gains new properties. PtCo alloys are very good examples to clarify this situation due to magnetic properties [11]. Platinum is naturally nonmagnetic material so it has not got any magnetic moment [12]. When it composes itself with ferromagnetic cobalt, it gains some net magnetic moment and starts behaving as a magnetic material as a paramagnetic and also changes the magnetic properties of cobalt [13]. For example, the magnetocrystalline anisotropy is a key parameter for data storage media. Pt affects the magnetocrystalline anisotropy of cobalt. The magnetocrystal- line anisotropy constant of Cobalt (410 KJ·m$^{-3}$) [14] is ten times smaller than the magnetocrystalline anisotropy constant of PtCo (4.9 MJ·m$^{-3}$) [14]. SmCo$_5$ are used now for data storage media, and the magnetocrystalline anisotropy
constant PtCo is very close to SmCo5’s (17.2 MJ⋅m−3) [14], so PtCo alloy still is an active research area and the one of good candidates is for next generation data storage media [15]. Besides their magnetic properties, PtCo alloys also have catalytic properties [16–20]. Another most important point is that they can be prepared easily in different chemical ratios, and their phase is very stable [21]. We believe that if these structures come into use in next generation magnetic data storage media, their electrical properties may be gained significantly.

The other hand semiconductor base materials exhibit an interesting combination of magnetic and electrical properties, which are essential for future generation spintronics device applications [22]. Two of these electrical properties are Schottky barriers (SB) and tunneling diode.

They can be used in microwave detector diodes [23]. Schottky diodes with low barrier height have some applications in devices operating as infrared detectors and imaging sensors at high frequencies [24, 25]. Schottky Metal (SM) contacts have an important role in electronic technology [26, 27]. Metal-semiconductor (MS) contact is one of the most widely used rectifying contacts in electronic industry [28, 29]. Electronic properties of a Schottky diode are characterized by its series resistance, barrier height, and ideality factor parameters [30, 31]. Schottky barrier height, and other characteristic parameters can affect device performance, stability and reliability [32–35]. Electrical properties of PtCo alloys have not been investigated so far. So in this study, we focused on surface and volume resistivity of different stoichiometry of PtCo alloys films. In order to realize this goal, we prepared three different chemical ratios of PtₙCo₁₋ₙ (x = 0.2, 0.5, 0.7) alloy films with magnetron sputtering technique at UHV conditions. X-ray photoelectron spectroscopy (XPS) was used for QCM calibration. Before synthesizing PtCo alloy films, both Pt and Co deposition ratios were calculated. PtₙCo₁₋ₙ (x: 0.2, 0.5, 0.7) alloy films were grown using cosputtering technique. The number of sequences was kept 100 for all samples; on the other hand, the Pt and Co deposition time was calculated depending on the chemical ratio of PtₙCo₁₋ₙ (x: 0.2, 0.5, 0.7) alloy films. The power applied to Co target was 30 Watt and the corresponding deposition rate was 0.3 Å/sec. The Pt deposition rate was 0.1 Å/sec with 2 Watt. The Pt and Co targets were operated at the same time, and the temperature was held at 350°C. The films thicknesses were 300 Å.

The current-voltage (I-V) and resistivity of the thin films were studied using a four-point probe measurement with the Lucas Signatone system. I-V and surface resistance were measured using a Keithley 2400 Source-Meter in a four-point probe technique and converted to the surface resistivity. The I-V and surface resistance measurements were carried out at room temperature.

3. Result and Discussion

XPS was used to determine the selected chemical ratios of alloy films in situ. Figure 1 shows survey XPS spectra for Pt₀.₃Co₀.₇ and Pt₀.₇Co₀.₃. High resolution XPS spectra for the major photoemission Co 2p and Pt 4f regions were also taken (Figure 2) for analysis in commercial software CasaXPS 2.3.14. We used the Shirley background function to fit and analyze the peaks. The Voigt function identifying the photoemission nature was used to calculate the peak area of Co and Pt. The calculated peak areas of Co and Pt were divided by the atomic sensitivity factors (ASFs) which depend on both elemental properties and XPS setup (3.59 for Pt 4f, and 5.75 for Co 2p). The calculated Pt to Co ratios within alloy films are 20:80; 50:50, and 70:30.

Besides these analyses, the XPS spectra were given both Pt peaks and Co peaks from both their pure and the Pt₀.₄Co₀.₆ films (Figure 3). Because of their alloy form, both Pt and Co peaks came from Pt₀.₄Co₀.₆ films; they are shifted from the low binding energy value to the high binding energy value. Their peak shape also expanded due to their chemical bonding.

The typical forwarded bias voltage (V) and current (I) characteristics obtained from the samples are shown in Figure 4. I-V curves of the samples are linear at low bias voltage and nonlinear at high bias voltage. All the curves
show an intersection at low forward biases (about 0.1-0.2 V). The I-V curve quickly (at low forward bias) becomes dominant with a resistance from contact wires or bulk resistance of the samples. If the current passes through MS Schottky diode at a forward bias voltage \(3kT/q \leq V\), a high resistive potential barrier created by grains is considered in these systems [36]. The observed results require a serial resistance [37]. Serial or parasitic resistance, \(R_s\), includes bulk and contact resistances. The I-V results deviated from ideality can be explained by thermionic emission theory with a serial resistance. The TE model considers that I-V characteristic of an MS type Schottky diode is given as follows [38]:

\[
I = I_o \exp \left( \frac{q(V - IR_s)}{nkT} \right) \left[ 1 - \exp \left( - \frac{q(V - IR_s)}{kT} \right) \right],
\]

where \(q\) is electron charge, \(k\) is Boltzmann constant, \(T\) is absolute temperature, \(n\) is ideality factor (close to 1), and finally \(I_o\) is saturation current. \(V - IR_s\) is voltage drop across the diode. The saturation current can be written as

\[
I_o = A A^* T^2 \exp \left( - \frac{q\phi_b}{kT} \right),
\]

where \(\phi_b\), \(A\), and \(A^*\) are apparent barrier height, effective contact area, and Richardson constant, respectively. All these physical parameters have an importance for technological application. Richardson constant is equal to 32 A cm\(^{-2}\) K\(^{-2}\) for p-type Si [39]. The saturation current can be obtained from an extrapolation to current axis in I-V plot at zero bias voltage. At relatively high forward bias voltages, the parasitic or serial resistance goes to a constant value. In general, low serial resistance is required for a device application [40, 41].
Figure 3: The comparison of both Pt 4f and Co 2p peaks that came from both their pure films and Pt$_{0.6}$Co$_{0.4}$ films.

Figure 4: Current-voltage graph and inset: $dV/d(ln I)$ – $I$ plot.

The series resistance, ideality factor, and barrier height are determined by using Cheung’s functions as follows [42]:

\[
\frac{dV}{d(ln I)} = I R_s + \frac{n k T}{q},
\]

(3)

\[
H(I) = V(I) - \frac{n k T}{q} \ln \left( \frac{I}{A A^* T^2} \right),
\]

(4)

and another form of $H(I)$ function is given as follows:

\[
H(I) = n \phi_b + I R_s,
\]

(5)

The $dV/d(ln I) – I$ plot is shown in inset of Figure 4. All curves are straight lines with low and different slopes. The ideality factor can be obtained by using (3) from the slope of the linear curves. The obtained values of the ideality factor are given in Table 1. It is clear from the table that the values
Table 1: I-V characteristics parameters of the samples.

<table>
<thead>
<tr>
<th></th>
<th>$R_s$ (Ω)</th>
<th>$n$</th>
<th>$\phi_b$ (eV)</th>
</tr>
</thead>
<tbody>
<tr>
<td>$x = 0.2$</td>
<td>3.89</td>
<td>1.32</td>
<td>0.26</td>
</tr>
<tr>
<td>$x = 0.5$</td>
<td>6.64</td>
<td>1.83</td>
<td>0.27</td>
</tr>
<tr>
<td>$x = 0.7$</td>
<td>4.60</td>
<td>1.03</td>
<td>0.25</td>
</tr>
</tbody>
</table>

of the ideality factor for the samples are really low. The low values (~1) of the ideality factor may result from homogeneity of film thickness [43], series resistance effect, low interface state, and the interface charges.

The simple analysis of (5) yields $n$ and $\phi_b$ parameters. The change in $R_s$, $n$, and $\phi_b$ with composition at room temperature is shown in Table 1. It is clear from the data obtained from Figure 4 that the parameters have strong composition dependence.

4. Conclusion

This work indicates that coating of p-type Si (100) with Pt_{x}Co_{1-x} alloys thin films can be prepared by Magnetron Sputtering Deposition at UHV condition. XPS was used for three different goals. One was to determine the deposition rate of cobalt and platinum. The other one was determination of the chemical ratio of PtCo alloy films. The last one was that the PtCo alloy forms were proved by XPS results. The performance and reliability of metal-semiconductor or metal-insulator-semiconductor diodes depend on barrier height, properties of interface layer, and $R_s$ I-V characteristics of the samples were investigated at room temperature. The nonideal type I-V behavior observed was attributed to a serial resistance in the MS type Schottky diode. The serial resistances were found to be 3.89Ω, 6.64Ω and 4.60Ω for $x = 0.2$, 0.5, and 0.7, respectively.

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